FIG. 1

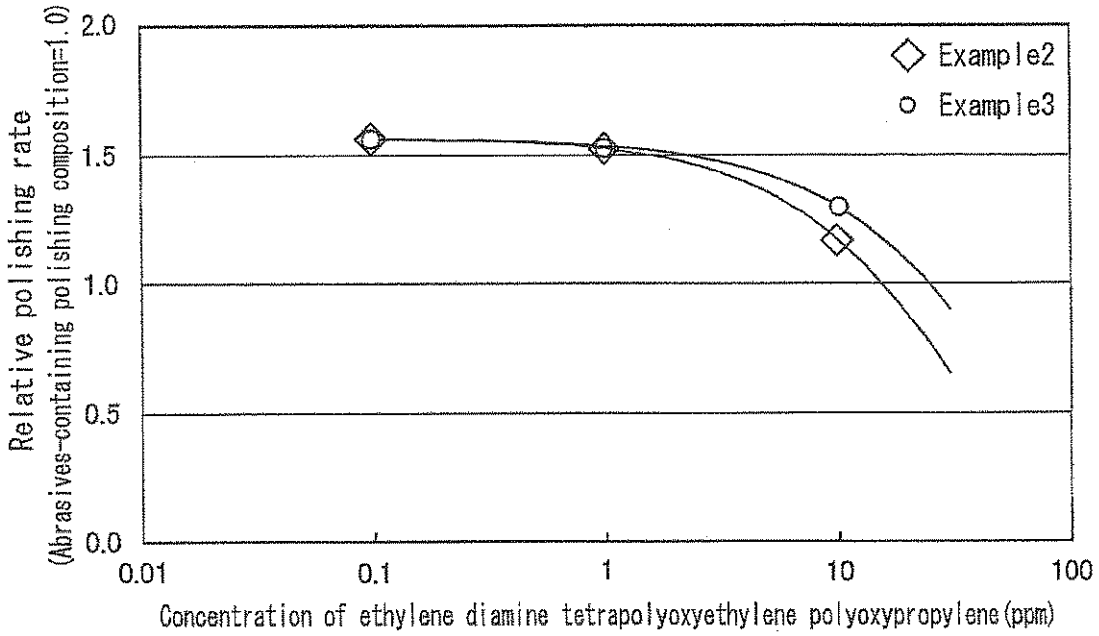

Relative polishing rate
(Abrasives-containing polishing composition=1.0)
2.0
1.5
1.0
0.5
0.0
0.01
0.1
1
10
100
Example2
Example3
Concentration of ethylene diamine tetrapolyoxyethylene polyoxypropylene(ppm)

FIG. 2

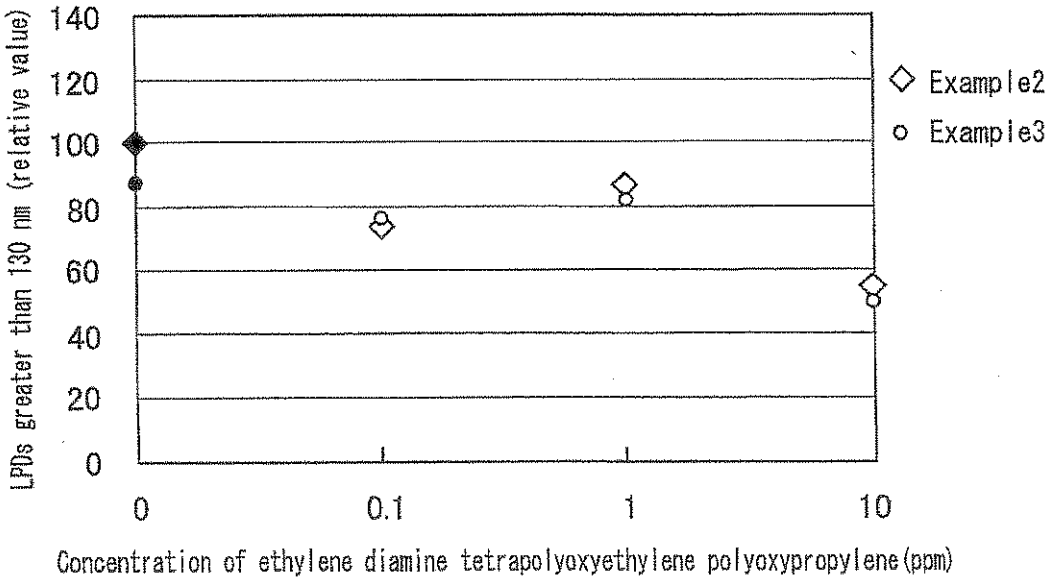

LPDs greater than 130 nm (relative value)
140
120
100
80
60
40
20
0
0
0.1
1
10
Example2
Example3
Concentration of ethylene diamine tetrapolyoxyethylene polyoxypropylene(ppm)

FIG. 3

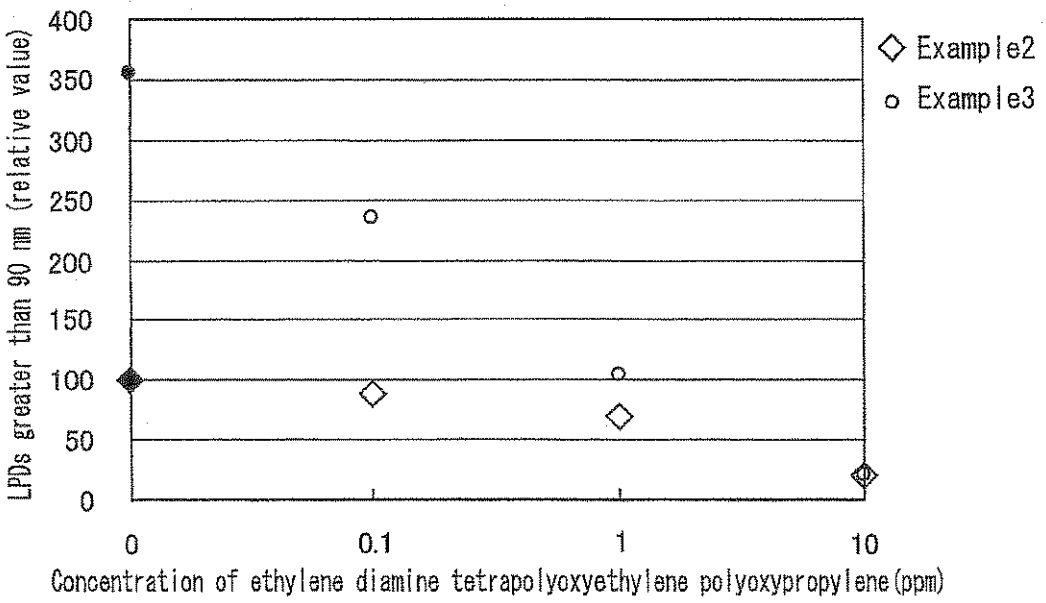

400
350
300
250
200
150
100
50
0
LPDs greater than 90 nm (relative value)
0
0.1
1
10
Concentration of ethylene diamine tetrapolyoxyethylene polyoxypropylene(ppm)
Example2
Example3

FIG. 4

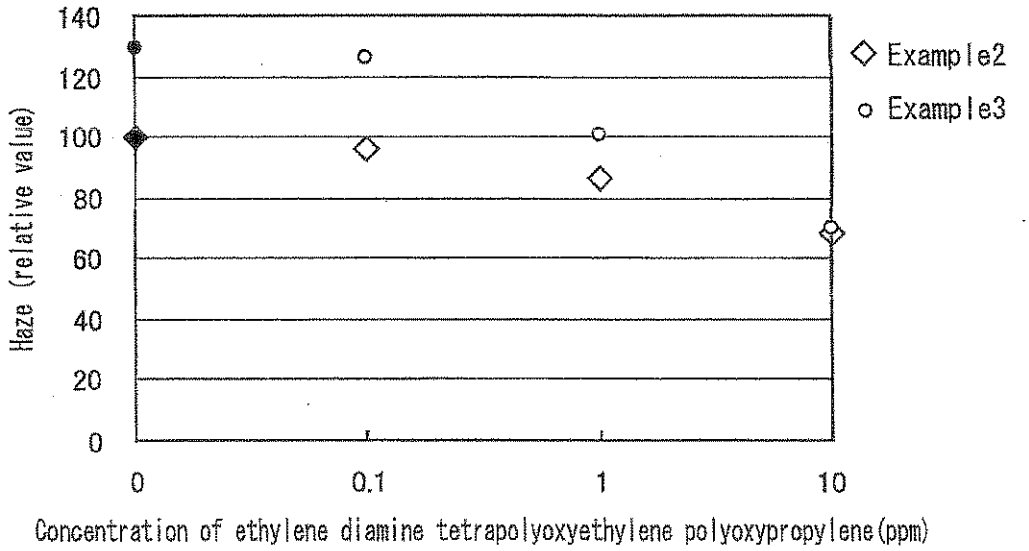

140
120
100
80
60
40
20
0
Haze (relative value)
0
0.1
1
10
Concentration of ethylene diamine tetrapolyoxyethylene polyoxypropylene(ppm)
Example2
Example3

FIG. 5

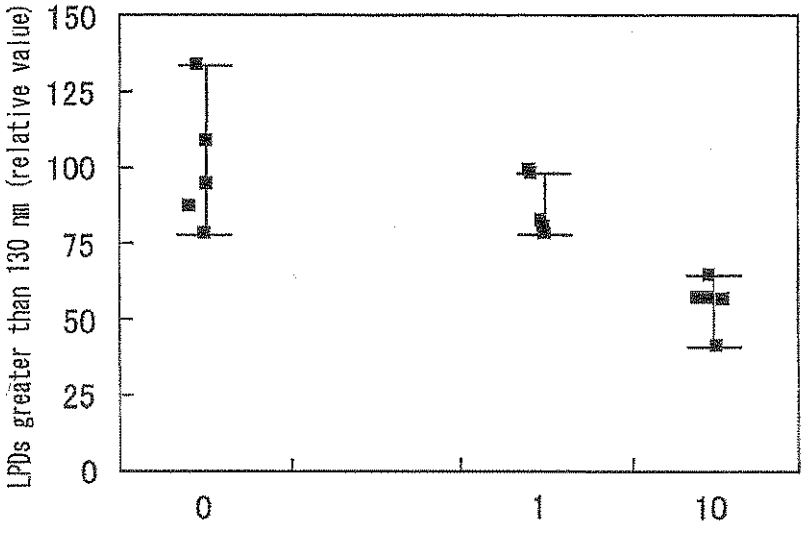

LPDs greater than 130 nm (relative value)
150
125
100
75
50
25
0
0
1
10
Concentration of ethylene diamine tetrapolyoxyethylene polyoxypropylene(ppm)

FIG. 6

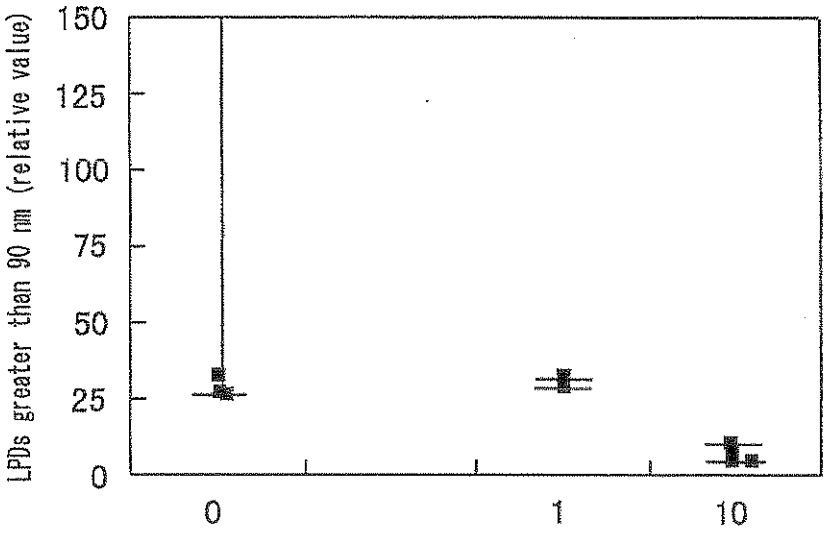
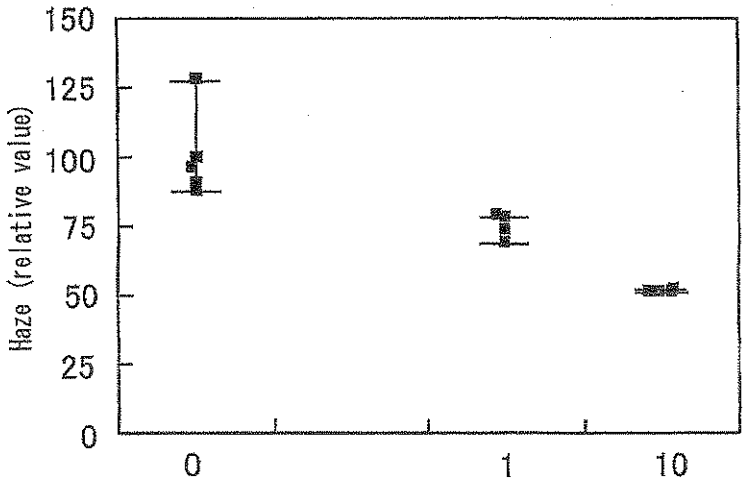

LPDs greater than 90 nm (relative value)
150
125
100
75
50
25
0
0
1
10
Concentration of ethylene diamine tetrapolyoxyethylene polyoxypropylene(ppm)

FIG. 7


150
125
100
75
50
25
0
Haze (relative value)
0
1
10
Concentration of ethylene diamine tetrapolyoxyethylene polyoxypropylene(ppm)